

**Snell & Wilmer**  
L.L.P.  
LAW OFFICES

One Arizona Center  
Phoenix, Arizona 85004-2202  
(602) 382-4000  
Fax (602) 382-6070  
[www.swlaw.com](http://www.swlaw.com)

PHOENIX, ARIZONA  
TUCSON, ARIZONA  
IRVING, CALIFORNIA  
SALT LAKE CITY, UTAH  
DENVER, COLORADO  
LAS VEGAS, NEVADA

## FACSIMILE TRANSMISSION

#22/C  
VI  
C1034

DATE: June 19, 2003

TIME IN:  
TIME OUT:

TO:	Name	Fax Number	Phone Number
	Eileen Morgan USPTO - Art Unit 3723	(703)308-6642	

FROM: Laura Zeman

PHONE: 602-382-6377

RE: Serial No. 09/008,148

MESSAGE:

Per your request, please see attached abstract.

ORIGINAL DOCUMENT: Will not be sent

NUMBER OF PAGES (including Cover): 2

CONFIRMATION NO.:

CLIENT MATTER NO.: 28131.0217

PLEASE RETURN TO:

Kim Wilson 16S21 PERSONAL FAX:

No

REQUESTOR:

Laura Zeman

DIRECT LINE:

602-382-6377

IF YOU HAVE NOT PROPERLY RECEIVED THIS TELECOPY, PLEASE CALL US AT (602) 382-6075.  
OUR FACSIMILE NUMBER IS (602) 382-6070.

THE INFORMATION CONTAINED IN THIS FACSIMILE MESSAGE IS ATTORNEY PRIVILEGED AND CONFIDENTIAL INFORMATION INTENDED ONLY FOR THE USE OF THE INDIVIDUAL OR ENTITY NAMED ABOVE. IF THE READER OF THIS MESSAGE IS NOT THE INTENDED RECIPIENT, OR THE EMPLOYEE OR AGENT RESPONSIBLE TO DELIVER IT TO THE INTENDED RECIPIENT, YOU ARE HEREBY NOTIFIED THAT ANY DISSEMINATION, DISTRIBUTION OR COPYING OF THIS COMMUNICATION IS STRICTLY PROHIBITED. IF YOU HAVE RECEIVED THIS COMMUNICATION IN ERROR, PLEASE IMMEDIATELY NOTIFY US BY TELEPHONE, AND RETURN THE ORIGINAL MESSAGE TO US AT THE ABOVE ADDRESS VIA THE U.S. POSTAL SERVICE. THANK YOU.

Abstract

Method and apparatus for chemically and mechanically planarizing the surface of a silicon wafer which includes a compressible non-cellular lapping surface and a shunt disposed between the wafer and the lapping surface.